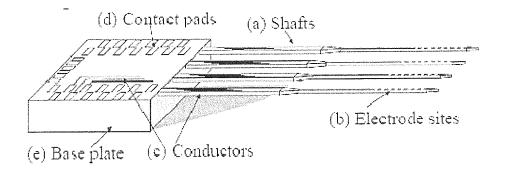
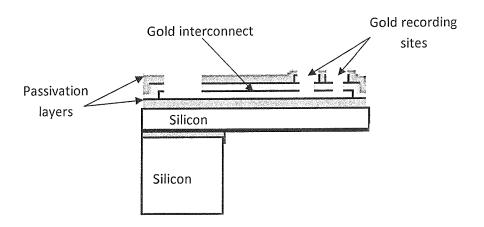
The following ten questions are qualitative and examine your basic knowledge of BioMEMS. They all have short answers. If needed, you can draw a schematic to explain your answers.

- 1) Name two chemical used for anisotropic etching of silicon. (5 points)
- 2) Stiction is a common problem encountered in releasing surface micromachined structures, name two methods to prevent stiction. (5 points)
- 3) What is SU8 and where it is used the most? (5 points)
- 4) Name two reasons why PDMS is a good substrate for microfluidics. (5 points)
- 5) Name two advantages of capacitive sensing over piezoresistive sensing. (5 points)
- 6) What is Reynold # and why it is important in microfluidics? (5 points)
- 7) What is electric double layer capacitance? (5 points)
- 8) Why do you need to remove silicon from underneath thermal sensors? (5 points)
- 9) Can you measure a physiological signal having a close to DC frequency response with a piezoelectric sensor? Explain your answer (5 points)
- 10) Commercial glucose sensors are electrochemical amperometric sensors. What do we mean by "electrochemical amperometric"? (5 points)



A) The following figure show schematic and cross section of a silicon neural probe fabricated using bulk micromaching on an SOI (silicon on insulator) wafer. Draw the fabrication sequence used to fabricate such probes. Explain each step and count the total # of masks needed. (20 Points)





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B) A cantilever biosensor is designed to be actuated piezoelectrically using ZnO and its vibration to be detected optically using a lever system similar to atomic force microscopes (AFM). Draw a cross-section of the device and label all layers and components (15 Points)

C) Write down the force between two plates of a parallel plate capacitor connected to a battery in terms of voltage and geometrical parameters (A is the area of the capacitor and d is the gap. Assume the gap is air). Now assume that you scale all dimensions by a factor of s (e.g., if s=0.1 you reduce all linear dimensions by a factor of 10). How does the electrostatic force between the plates scale with s? Comment on scaling differences between electrostatic and magnetic force in the microdomain. (15 points)

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